

PATENT  
Att. DKL AMAT/3819/DSM/WBCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
Suzuki, et al.

Serial No.: 10/004,489

Confirmation No.: 9428

Filed: October 23, 2001

For: **Method of Forming Film,  
Method of Manufacturing  
Semiconductor Device and  
Film Forming Apparatus**

MAIL STOP 313(c)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2818

Examiner: Renee R. Berry

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FEB 10 2005

## OFFICE OF PETITIONS

**CERTIFICATE OF FACSIMILE  
TRANSMISSION UNDER 37 CFR 1.8**

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2/10/05 Kevin 2/10

Date Signature

**PETITION FOR WITHDRAWAL FROM ISSUANCE  
UNDER 37 C.F.R. §1.313(c)(3)—EXPRESS ABANDONMENT**

Applicants petition under Rule 313(c)(3) for withdrawal of the application from issuance for express abandonment of the application. The Commissioner is hereby authorized to charge the petition fee of \$130.00 to Deposit Account No. 20-0782/AMAT/3819/KMT.

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Respectfully submitted,

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## **FACSIMILE COVER SHEET**

**DATE:** February 10, 2005  
**FILE NO:** AMAT/3819/DSM/BCVD/JW  
**TO:** MAIL STOP 313(c)  
**FAX NO:** 571-273-0025  
**COMPANY:** USPTO  
**FROM:** Keith M. Tackett  
**PAGE(S) with cover:** 3

**ORIGINAL TO FOLLOW?**  YES  NO

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### **PETITION FOR WITHDRAWAL FROM ISSUANCE UNDER 37 C.F.R. (c)(3) AND EXPRESS ABANDONMENT AFTER PAYMENT OF ISSUE FEE**

**TITLE:** Method of Forming Film, Method of Manufacturing Semiconductor Device and Film Forming Apparatus  
**U.S. SERIAL NO.:** 10/004,489  
**FILING DATE:** October 23, 2001  
**INVENTOR:** Suzuki, et al.  
**EXAMINER:** Renee R. Berry  
**GROUP ART UNIT:** 2818  
**CONFIRMATION NO.:** 9428

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